	Application/Control No.	Applicant(s)/Patent Under Reexamination
Search Notes	10567028	PICKLES ET AL.
*1056702	Examiner	Art Unit
1030/02	Jennifer Dieterle	1759
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SEARCHED				
Class	Subclass	Date	Examiner	
204	400, 415, 416, 418	4/23/09	JMD	
Updated above		5/25/10	JMD	
204	400,409,433,412,406,408,410,411,415,416,421,422,434, 280	12/12/10	JMD	
205		12/12/10	JMD	

SEARCH NOTES			
Search Notes	Date	Examiner	
EAST, Google, Inventor	4/23/09	JMD	
Spoke with Kaj Olsen concerning applicant's amendments and verified art is applicable to make rejection final	10/12/09	JMD	
Consulted with Kaj Olsen, also consulted with Alen Olsen concerning etching processes, both indicated that my prior art Shiomi is applicable.	5/25/10	JMD	
EAST, Google, Inventor, consulted with Kaj Olsen	12/12/10	JMD	

INTERFERENCE SEARCH				
Class	Subclass	Date	Examiner	
	interference text search of claim language	12/12/10	JMD	
205	775,782.5,786.5,787.5,793,794.5	12/12/10	JMD	
204	400,409,433,412,406,408,410,411,415,416,421,422,434, 280	12/12/10	JMD	

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